

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 29, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

LG649431016

LABORATORY GROWN DIAMOND

EMERALD CUT

8.47 X 5.96 X 3.71 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.87 CARAT

F

VS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG649431016

PROPORTIONS

Medium

67%

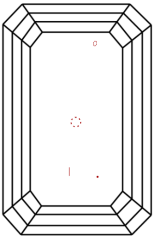
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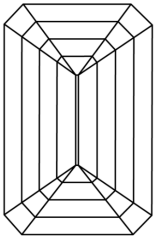
46%

62.2%

Long

CLARITY CHARACTERISTICS






KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

CLARITY

D E F G H I J

Faint

Very Light

Light

IF

VS ¹⁻²

VS ¹⁻²

SI ¹⁻²

I ¹⁻³



Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included


Included



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Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.87 CARAT

F

VS 2

62.2%

67%


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